IFW 2615



Attorney Docket no: SEL 249

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		I hereby certify that this correspondence is being deposited
Hajime KIMURA) with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,
Serial No.:	09/829,114	P.O. Box 1450, Alexandria, VA 22313-1450 on
Filed:	April 9, 2001	(Date of Deposit)
For: Semiconductor Device And Method Of Driving The Same		Shannon Wallace Name of applicant, assignee, or Registered Rep. Signature Shannon Wallace Name of applicant, assignee, or Registered Rep. Date
Examiner:	Yogesh K. Aggarwal)
Art Unit:	2615))

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT E

In response to the Office Action of March 3, 2006, please amend the above-identified application as follows: